

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: :  
Ellison et al. : Attorney Docket: 31257-252090  
Application No.: 10/526,059 : Art Unit: 4174  
Filed: October 13, 2005 : Examiner: N. Gugliotta  
Title: LIGHTLY DOPED SILICON CARBIDE WAFER AND USE THEREOF IN HIGH  
POWER DEVICES

RESPONSE TO FINAL OFFICE ACTION

MAILSTOP AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Sir:

In response to the final office action issued May 23, 2008, please amend the above-identified application as follows: